OK TO ENTER: /R.S.W./

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: FUJIEDA, Tsukasa

Group Art Unit: 1717

Serial No.: 10/576,193

Examiner: WALTERS Jr., Robert S.

Filed: April 17, 2006

P.T.O. Confirmation No.: 8608

For: METHOD OF FORMING LUSTER COATING FILM

## RESPONSE UNDER 37 CFR §1.116 - EXPEDITED RESPONSE GROUP ART UNIT 1717

## **MAILSTOP AF**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

December 28, 2011

Sir:

In response to the Office Action dated September 29, 2011, the following remarks are respectfully submitted:

Remarks/Arguments begin on page 2 of this paper.